

<b>Notice of References Cited</b>	Application/Control No. 10/663,402	Applicant(s)/Patent Under Reexamination FARNWORTH ET AL.	
	Examiner Vivian Chen	Art Unit 1773	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Rapid Prototyping Directly from the Vapor Phase", Science, vol. 267, 3/3/1995 (abstract)
	V	"Fabrication of Advanced Thermionic Emitters Using Laser Chemical Vapor Deposition-Rapid Prototyping", Solid Freeform Fabrication Proceedings, 2000 (abstract).
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.